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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: K. Aratani, et al.

Serial No.: 09/429,719

Filed: October 29, 1999

For: THIN FILM FORMATION USE
SPUTTERING TARGET MATERIAL,
THIN FILM FORMED USING SAME,
AND OPTICAL RECORDING MEDIUM

Case No.: 9792486-0100

Group Art Unit: 1753

Examiner: R. McDonald

Date: September 12, 2001

Certificate of Mailing (37 CFR 1.8(a))

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to:

Assistant Commissioner for Patents
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Date of Deposit: September 12, 2001

JoEllen Hogan 9/12/01
JoEllen Hogan Date

TRANSMITTAL LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed herewith is an Amendment "C" After Final of K. Aratani, et al. in the above-identified patent application entitled THIN FILM FORMATION USE SPUTTERING TARGET MATERIAL, THIN FILM FORMED USING SAME, AND OPTICAL RECORDING MEDIUM.

Also enclosed are: Request for One Month Extension of Time
Check in the amount of \$110.00
Affidavit Under 37 CFR 1.131
Return Receipt Postcard

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered, to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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